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103-37PATENT
Atty. Dkt. APPM/3421.C1/CPI/COPPER/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Cheung, et al.

Serial No.: 09/609,347

Confirmation No.: 5540

Filed: July 5, 2000

For: Apparatus for Electro-
Chemical Deposition of
Copper Metallization With
the Capability of In-Situ
Thermal AnnealingAssistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1741

Examiner: E. Hicks

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GROUP 1700CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, E. Hicks, fax number 703-872-9311 to the attention of the named Examiner, E. Hicks, on the date below.

3/26/2002

Date

Rob D Edwards

Signature

RESPONSE TO RESTRICTION REQUIREMENT

In response to the Restriction Requirement dated February 26, 2002, having a thirty day response period set to expire on March 26, 2002, Applicants provisionally elect claims 1-11 and 18-20, with traverse, and request reconsideration of the pending restriction requirement for reasons discussed below. The Commissioner is authorized to charge \$738.00 for three additional independent claims and twenty-seven total new claims to Deposit Account No. 20-0782/3421.C1/CPI/COPPER/BTP, along with any other fees to make this response timely.

IN THE CLAIMS:

Please amend the claims as follows: